

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Eran Dvir, Moshe Finarov, Eli Haimovich, Benjamin Shulman  
 Assignee: Nova Measuring Instruments, Ltd.  
 Title: Apparatus For Optical Inspection Of Wafers During Polishing  
 Serial No.: 09/498,926 Filing Date: February 4, 2000  
 Examiner: E. Morgan Group Art Unit: 3723  
 Docket No.: M-3417-2C US

San Jose, California  
 November 15, 2000

COMMISSIONER FOR PATENTS  
 Washington, D.C. 20231

**ASSOCIATE POWER OF ATTORNEY (37 C.F.R. § 1.34)**

Dear Sir:

The undersigned Attorney of Record hereby appoints the attorney named below as an Associate Attorney in the above-identified application with full powers to prosecute said application; to make alterations and amendments therein; to receive all notices, communications and said Letters Patent at the address indicated below; and to transact all business in the U.S. Patent and Trademark Office in connection therewith.

The undersigned Attorney of Record hereby appoints:

Jerome R. Smith, Jr., Reg. No. 35,684

Please address all further correspondence in the above case to:

David W. Heid  
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 Telephone (408) 453-9200  
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I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

*David W. Heid*  
 Signature Date 11/15/00

Respectfully submitted,

*David W. Heid*  
 David W. Heid  
 Attorney for Applicants  
 Reg. No. 25,875

Attorney Docket No. M-3417 US

ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, we

Eran Dvir of 15 Hapalmach St., Givatayim 53406, Israel  
Moshe Finarov of 4/25 Shkolnik St., Rehovot 76209, Israel  
Eli Haimovich of 23 Haarava St., Moshav Magshimim 56910, Israel  
Benjamin Shulman of 524/20 Hagana St., Rehovot 76100, Israel

hereby sell, assign and transfer to Nova Measuring Instruments, Ltd., an Israeli corporation, having a place of business at Weizmann Scientific Park, P.O.Box 266, Rehovot 76100, Israel, its successors and assigns, the entire right, title and interest throughout the world in our invention in

APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

the specification of which was filed on June 29, 1995 and assigned Serial No. 08/497,382, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; we authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from us; we agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, their successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and we request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Executed this 1 day of 10, 1995.

Eran Dvir  
(Full Name)

  
(Inventor's Signature)

Witness:

Witness:

Executed this 1 day of 10, 1995.

Moshe Finarov  
(Full Name)

  
(Inventor's Signature)

Witness:

Witness:

Attorney Docket No. M-3417 US


Executed this 1 day of 10, 1995.Eli Haimovich  
(Full Name)Eli Haimovich  
(Inventor's Signature)Witness: Giora Dishon G.D.Witness: Judith Gethilf Y. GethilfExecuted this 1 day of 10, 1995.Benjamin Shulman  
(Full Name)Benjamin Shulman  
(Inventor's Signature)Witness: Giora Dishon G.D.Witness: Judith Gethilf Y. Gethilf

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## FACSIMILE COVER SHEET

Date: November 15, 2000  
To: Examiner Eileen P. Morgan  
U.S. Patent and Trademark Office

Fax Telephone #: 703-305-3579  
Office Telephone #: 703-308-1743

From: David W. Heid   
Subject: Attached Power of Attorney  
Client/File: M-3617-2C US

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Please deliver to Examiner Eileen P. Morgan

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**ENCLOSED:**

1. Associate Power of Attorney (1 page)

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